

Notice of References Cited	Application/Control No. 10/784,967	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Ida M. Soward	Art Unit 2822	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,806,111	10-2004	Ehrichs et al.	438/29
	B	US-2002/0181915	12-2002	Craig et al.	385/131
	C	US-2002/0131727	09-2002	Reedy et al.	385/88
	D	US-2003/0020121	01-2003	Rockwell et al.	257/378
	E	US-5,565,676	10-1996	Tanabe et al.	250/340
	F	US-6,758,608	07-2004	Van Arendonk et al.	385/89
	G	US-5,223,919	06-1993	Whight et al.	257/459
	H	US-6,693,736	02-2004	Yoshimura et al.	359/333
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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	X	

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